

<b>Search Notes</b> 	<b>Application/Control No.</b>	<b>Applicant(s)/Patent under Reexamination</b>
	10/006,308	DOE ET AL.
	<b>Examiner</b> Longbit Chai	<b>Art Unit</b> 2131

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
713	182-185 193-194	3/17/07 (update)	JMC
380	30;232	3/16/07 (update)	JMC
726	3-6 16-21	3/16/07 (update)	JMC